



PATENT  
Docket No. 492322014700

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the application of:

Yasuo SEGAWA *et al.*

Serial No.: 10/705,223

Filing Date: November 12, 2003

For: SEMICONDUCTOR DEVICE WITH  
ISOLATED STORAGE CAPACITOR  
AND ITS MANUFACTURING  
METHOD

Examiner: Kevin V. Quinto

Group Art Unit: 2826

**PETITION TO WITHDRAW APPLICATION FROM ISSUE UNDER 37 CFR 1.313(c)(2)**

Mail Stop Petition  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Applicants petition under 37 CFR 1.313(c)(2) for withdrawal of this application from issue to permit a Request for Continued Examination that is attached to this petition.


This application was allowed, and the issue fee was paid on May 20, 2005. However, applicants believe that the two Japanese Patent Application Publications cited in a Chinese Action dated April 8, 2005 and listed in the Information Disclosure Statement under 37 CFR 1.97 attached to the RCE may be relevant to the examination of this application and should be considered before a patent issues on this application.

Accordingly, applicants respectfully request the withdrawal of this application from issue to permit continued examination of this application based on the Information Disclosure Statement.

In the event that the transmittal letter is separated from this document and the Patent and Trademark Office determines that an extension and/or other relief is required, applicants petition for any required relief including extensions of time and authorize the Commissioner to charge the cost of such petitions and/or other fees due in connection with the filing of this document to **Deposit Account No. 03-1952**, referencing Docket No. 492322014700.

Respectfully submitted,

Dated: July 25, 2005

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